

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

For: METHOD AND SYSTEM FOR DETECTION OF SOLID MATERIALS IN A PLASMA USING AN ELECTROMAGNETIC CIRCUIT

VIA EFS WEB
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This response is submitted in response to the Final Office Action dated December 8, 2009.

Please amend the Application as follows: